Search Notes				

Application/Control No. Applicant(s)/Patent under Reexamination	
10/533,396	OOTOMO ET AL.
Examiner	Art Unit
KEVIN L. LEE	3753

KEVIN L. LEE

SEARCHED				
Class	Subclass	Date	Examiner	
137	613 545 549 613 625.3	12/30/2007	KL	

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		

SEARCH NOT (INCLUDING SEARCH	ES STRATEGY)
	DATE	EXMR
EAST search (inventor name search)	12/30/2007	KL